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**7<sup>th</sup> International Conference on Technological Advances of Thin  
Films & Surface Coatings (THINFILMS2014)**

**15<sup>th</sup> - 18<sup>th</sup> July 2014, Chongqing, China**

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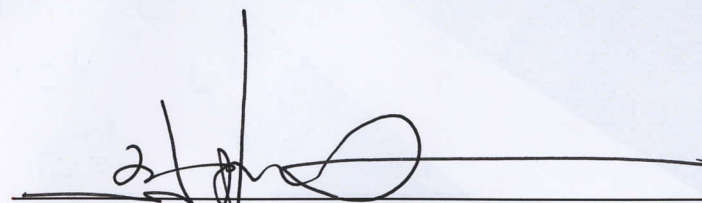
**Poster Award – Third Prize Winner**

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**ETF2253: Effect of Sputtering Parameters on Surface Morphologies of  
Sn Thin Films**

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**President, TFS  
Chairman, THINFILMS2014**